

RECEIVED
CENTRAL FAX CENTER

DEC 02 2005

PATENT

Docket No.: 2336-256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Ju Hyun KIM *et al.*

U.S. Patent Application No. 10/810,634

Filed: March 29, 2004

Confirmation No. 9586

Group Art Unit: 2812

Examiner: Fernando L Toledo

For: METHOD FOR SEPARATING SAPPHIRE WAFER INTO CHIPS USING DRY-ETCHING

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

- ☒ No additional fee is required.
- ☐ Small entity status of this application has been established.
- ☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	18	20	0	x \$ 50 =	\$0
Independent Claims	3	3	0	x \$200 =	\$0
If multiple claims newly presented, add \$360.00					-----
Fee for extension of time					-----
TOTAL FEE DUE					\$0

- ☐ A credit card authorization form in the amount of _____ is attached
- ☒ The Commissioner is hereby authorized to charge payment of any *deficiency* in fees associated with this communication or credit any overpayment, to Deposit Account No. 07-1337, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

LOWE HAUPTMAN & BERNER, LLP

Benjamin J. Hauptman
Registration No.: 29,310USPTO Customer No. 22429
1700 Diagonal Road, Suite 300
Alexandria, Virginia 22314
(703) 684-1111 BJH/klb
(703) 518-5499 Facsimile
Date: December 2, 2005CERTIFICATION OF FACSIMILE TRANSMISSION
I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMILE TRANSMITTED
TO THE PATENT AND TRADEMARK OFFICE ON THE DATE SHOWN BELOW

TYPE OR PRINT NAME OF PERSON SIGNING CERTIFICATION

SIGNATURE

December 2, 2005
DATE571-273-8300
FACSIMILE NUMBER

BEST AVAILABLE COPY

RECEIVED
CENTRAL FAX CENTER

DEC 02 2005

PATENT

Docket No.: 2336-256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Ju Hyun KIM *et al.*

U.S. Patent Application No. 10/810,634

Filed: March 29, 2004

For: METHOD FOR SEPARATING SAPPHIRE WAFER INTO CHIPS USING DRY-
ETCHING

: Confirmation No. 9586

: Group Art Unit: 2812

: Examiner: Fernando L Toledo

AMENDMENT

COMMISSIONER FOR PATENTS

P.O. Box 1450

Alexandria VA 22313-1450

Sir:

The following amendments and remarks are submitted in response to the Official Action dated September 2, 2005.

CERTIFICATION OF FACSIMILE TRANSMISSION
I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMILE TRANSMITTED
TO THE PATENT AND TRADEMARK OFFICE ON THE DATE SHOWN BELOW

Kindra Bryant
TYPE OF PRINT NAME OF PERSON SIGNING CERTIFICATION

SIGNATURE

December 2, 2005
DATE571-273-8300
FACSIMILE NUMBER

BEST AVAILABLE COPY